Notice of Allowability	Application No.	Applicant(s)
	10/604,616	LAN, CHUNG-WEN
	Examiner	Art Unit
	Felisa C. Hiteshew	1765
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this a or other appropriate communication IGHTS. This application is subject and MPEP 1308.	pplication. If not included
1. This communication is responsive to the application filed on	<u>n August 5, 2003</u> .	
2. The allowed claim(s) is/are <u>1-6 and 18-20</u> .	•	
3. \boxtimes The drawings filed on <u>05 August 2003</u> are accepted by the	Examiner.	·
4. ☑ Acknowledgment is made of a claim for foreign priority un a) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have	been received.	
2. Certified copies of the priority documents have		
3. Copies of the certified copies of the priority doc	cuments have been received in this	national stage application from the
International Bureau (PCT Rule 17.2(a)). * Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give considered by the Notice of Draftspersor (a) including changes required by the Notice of Draftspersor (b) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicial such as the application number (see 37 CFR 1.1 each sheet. Replacement sheet(s) should be labeled as such in the considered examiner's comment regarding REQUIREMENT F.	ENT of this application. Itted. Note the attached EXAMINER is reason(s) why the oath or declarate to be submitted. It be submitted. It is patent Drawing Review (PTO Amendment / Comment or in the Comment or in the Comment or in the Grawler header according to 37 CFR 1.121(sit of BIOLOGICAL MATERIAL).	R'S AMENDMENT or NOTICE OF ation is deficient. -948) attached Office action of ngs in the front (not the back) of (d).
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date	6. ☐ Interview Summary Paper No./Mail Da 3), 7. ☐ Examiner's Amendr	te

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Priority

- Acknowledgment is made of applicant's claim for foreign priority under 35
 U.S.C. 119(a)-(d). The certified copy has been filed in parent Application No.
 10/604,880, filed on August 27, 2002. *Drawings*
- 2. Figure s 1-3 should be designated by a legend such as --Prior Art-- because only that which is old is illustrated. See MPEP § 608.02(g). Corrected drawings in compliance with 37 CFR 1.121(d) are required in reply to the Office action to avoid abandonment of the application. The replacement sheet(s) should be labeled "Replacement Sheet" in the page header (as per 37 CFR 1.121(d)) so as not to obstruct any portion of the drawing figures. If the examiner does not accept the changes, the applicant will be notified and informed of any required corrective action in the next Office action. The objection to the drawings will not be held in abeyance.

Allowable Subject Matter

1-9 are

- 3. Claims 1-6 and 18-20 are allowed.
- 4. The following is an examiner's statement of reasons for allowance: The most relevant prior art of record is that of U.S. Patent No.4,623,423 (Aubert, et al). However, it does not teach nor fairly suggest singularly or in any combination thereof an apparatus for growing stoichiometric lithium niobate and lithium tantalate single crystals, the apparatus comprising: a chamber, a crystal pulling system, a long crucible arranged inside the chamber; a separation member arranged in the lone crucible to divide an inner space of the long crucible into a melting zone and a feeding zone, wherein the melting zone is located above the feeding zone; a heating system surrounding a

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sidewall of the chamber; and a pushing/rotation system arranged under the long crucible to rotate and push the long crucible.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Felisa Hiteshew whose telephone number is (571) 272-1463. The examiner can normally be reached on Mondays through Thursdays from 5:30 AM to 3:00 PM. and second Fridays from 5:30 AM to 2:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton, can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is (571) 273-1463.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866- 217-9197 (toll-free).

Melion Setesher FELISA HITESHEW PRIMARY EXAMINER Ort Unit 1765